

RECEIVED
CENTRAL FAX CENTER

MAY 22 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:)	Docket No.:	2771-594-CIP
Applicants: WANG, Ziyun, et al.)	Conf. No.:	1841
Application No.: 10/699,079)	Art Unit:	1621
Date Filed: November 14, 2002)	Examiner:	Samuel A. Barts
Title: COMPOSITION AND METHOD FOR LOW TEMPERATURE DEPOSITION OF SILICON- CONTAINING FILMS)	Customer No.:	

23448

FACSIMILE TRANSMISSION CERTIFICATEATTN: Examiner Samuel A. Barts

Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission, addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, and transmitted on the date specified below, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

12
Number of Pages


Kate Pope

May 22, 2007
Date

**REQUEST FOR CONTINUED EXAMINATION AND ACCOMPANYING
AMENDMENT AND RESPONSE TO MARCH 22, 2007 FINAL OFFICE ACTION IN
U.S. PATENT APPLICATION NO. 10/699,079**

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the March 22, 2007 Final Office Action in the above-referenced application,

2771-594-CIP

applicants herein submit a Request for Continued Examination and this accompanying submission. Please enter this Amendment and Response into the file of the above-identified application

Please amend the claims of the above-identified patent application as set out in **Section I (Amendments to the Claims)** hereof.

Remarks concerning the amendments of the claims and the substance of the March 22, 2007 Office Action are set out in **Section II (Remarks)** hereof.